

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of: )  
LIOU et al. )  
Serial No.: 09/467,675 )  
Filed: Dec. 21, 1999 )  
For: Structure For ESD Protection With Single )  
Crystal Silicon Sided Junction )

Examiner: NADAV, O

Art Unit: 2811

Docket No.: 252103-4540

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on December 6, 2001.



Signature - Hui Chin Barnhill

FAX COPY RECEIVED

JUN 25 2002

TECHNOLOGY CENTER 2800

**RESPONSE TO OFFICE ACTION**

Assistant Commissioner of Patents and Trademarks  
Washington, DC 20231

Sir:

The Office Action mailed Aug. 13, 2001 (Paper No. 9), has been carefully considered. In response thereto, please consider the following remarks.

**REMARKS****Present Status of the Application**

The Office Action rejected all presently-pending claims 1-16 and 18-21. Specifically, the Office Action rejected claims 1-16 and 18-21 under 35 U.S.C. 103(a), as being unpatentable over Yamaguchi et al. (U.S. Patent 6,118,154) in view of Hu et al. (U.S. Patent 6,121,077), Erdeljac et